

AMENDMENTS TO THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in the application:

LISTING OF CLAIMS:

1-2. (canceled)

3. (currently amended) A method for manufacturing metallic material ~~on which~~ having a chromium-oxide passivation film ~~is formed thereon~~, comprising the ~~step~~ steps of:

~~forming the passivation film consisting of chromium oxide by applying heat treatment in an oxidizing atmosphere after coating chromium on the metallic material of the surface roughness (Ra) of metallic material surface is not more than 1.5 μ m~~

coating chromium onto a metallic material with a surface roughness (Ra) of not more than 1.5 μ m; and

applying a heat treatment to said chromium-coated metallic material in an oxidizing atmosphere so as to form metallic material having a chromium-oxide passivation film formed thereon.

4. (withdrawn) A fluid supplying/exhaust system for manufacturing semiconductors, comprising metallic material having a chromium-oxide passivation film according to claim 1.